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In re the Application of: SUGATANI, Shinji et al.

Group Art Unit: 2814

Serial No.: 10/634,839

Examiner: Howard Weiss

Filed: **August 6, 2003**

P.T.O. Confirmation No.: 8605

For. MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE AND SEMICONDUCTOR CHIP USING SOI SUBSTRATE

INFORMATION DISCLOSURE STATEMENT AND STATEMENT
PURSUANT TO 37 CFR 1.97(d)

Attn: Group Director

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

December 9, 2004

Sir:

The attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached Form PTO-1449. One copy of each document is attached.

This Information Disclosure Statement is submitted after the mailing of a final action, a Notice of Allowance, or an action that otherwise closes prosecution in the application, but on or before payment of the Issue Fee.

The undersigned hereby certifies that the foreign patent document AF contained in this statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

The above information is presented so that the Patent and Trademark Office can, in the first instance, determine any materiality thereof to the claimed invention. It is respectfully

requested that the information be expressly considered during the prosecution of this application, and that the documents cited in the attached Form PTO-1449 be made of record therein and appear on the first page of any patent to issue therefrom.

A check is attached hereto which covers the \$180.00 fee set forth in 37 CFR § 1.17(p). The Commissioner is hereby authorized to charge any additional fee (or credit any overpayment) associated with this Statement to our Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, KRATZ, QUINTOS, HANSON & BROOKS, LLP

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PATENT TRADEMARK OFFICE

Enclosures: PTO 1449; (1) reference

Chinese Office Action dated October 29, 2004 with partial translation

\$180.00 fee



INFORMATION OF INFORMATION
DISCLOSURE
CITATION
PTO-1449

Atty. Docket No. 021331A

Serial No. 10/634,839

Applicant(s): SUGATANI, Shinji, et al.

Filing Date: August 6, 2003

Group Art Unit: 2814

U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
	AA						
	AB						
	AC						
	AD						
	AE						

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Translation (Yes or No)
	AF	9-246505	09/19/1997	Japan	Abstract
	AG				
	AH				
<u> </u>	AI				
	AJ				

OTHER DOCUMENTS

	AK	Chinese Office Action dated October 29, 2004 with partial English-translation.
	AL	
Examiner		Date Considered